



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1430  
 Alexandria, Virginia 22313-1450  
[www.uspto.gov](http://www.uspto.gov)



Bib Data Sheet

CONFIRMATION NO. 8539

SERIAL NUMBER 10/645,908	FILING OR 371(c) DATE 08/22/2003 RULE	CLASS 438	GROUP ART UNIT 2891	ATTORNEY DOCKET NO. 2003_1164A
-----------------------------	--	--------------	------------------------	--------------------------------------

## APPLICANTS

Yoichiro Numasawa, Tokyo, JAPAN;  
 Yukinobu Murao, Tokyo, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\* *None AICS*

\*\* FOREIGN APPLICATIONS \*\*\*\*\* *Yes AICS*  
 JAPAN 2002-243342 08/23/2002

## IF REQUIRED, FOREIGN FILING LICENSE GRANTED

\*\* 08/29/2006

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY JAPAN	SHEETS DRAWING 5	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 2
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance Verifier and Acknowledged <i>As Sheawan Sankar</i> Examiner's Signature <i>Initials</i>				

## ADDRESS

513

## TITLE

Method of forming an oxygen- or nitrogen-terminated silicon nanocrystalline structure and an oxygen- or nitrogen-terminated silicon nanocrystalline structure formed by the method

FILING FEE RECEIVED 750	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit
----------------------------	---	---